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APPLICANTS

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** CONTINUING DATA ***** *None LV*

** FOREIGN APPLICATIONS ***** *None LV*

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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 15	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 8
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Verified and Acknowledged
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TITLE
 Etching method of hardly-etched material and semiconductor fabricating method and apparatus using the method

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